## Spin-dependent Tunneling in the Plasma Oxidized Cr<sub>2</sub>O<sub>3</sub> Barrier Magnetic Tunnel Junctions

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There has been growing interest in the antiferromagnetic spintronics due to the high-speed operation, no stray fields, and so on. [1] The magnetic tunnel junctions (MTJs) with the  $Cr_2O_3$  barrier would show the intriguing spin-dependent transport phenomena such as magnetoresistance (MR) effects based on antiferromagnetic and/or magnetoelectric nature of the  $Cr_2O_3$ . [2] However, it has not been addressed to the characterization of the ultrathin  $Cr_2O_3$  films to date. In this work, the spin-dependent transport properties in the MTJs with a  $Cr_2O_3$  barrier were investigated.

We fabricated the samples by a sputtering technique. The plasma oxidation was performed to form the  $Cr_2O_3$  barrier using the 90° off-axis cathode. The structural property of Si/SiO<sub>2</sub>/Ta(5)/Ru(20)/Co(4)/Cr<sub>2</sub>O<sub>3</sub>(20)/Ta(5) was characterized by using x-ray diffraction (XRD). The MTJ stack was composed of Si/SiO<sub>2</sub>/Ta(5)/Ru(20)/Co(4)/Cr<sub>2</sub>O<sub>3</sub>(2)/Co(3)/Ir<sub>22</sub>Mn<sub>78</sub>(10)/Ta(3)/Ru(7) (thickness in nm). The microfabrication of the MTJs were carried out using the photolithography and Ar ion milling, followed by post-annealing at 523 K under a magnetic field of 2 kOe. The transport properties were measured using the 4-terminal prober and the physical property measurement system.

The XRD  $2\theta/\omega$  scans showed the Cr<sub>2</sub>O<sub>3</sub> (006) peak although the (006) diffractions in the corundum oxides were weak in contrast to other peaks, indicating high orientation of Cr<sub>2</sub>O<sub>3</sub> to the (001) direction. For instance, the intensity ratio between (006) and (104) diffractions,  $I_{(006)}/I_{(104)}$ , in the Cr<sub>2</sub>O<sub>3</sub> powder sample was 0.15. On the contrary, sputtered Cr<sub>2</sub>O<sub>3</sub> showed the  $I_{(006)}/I_{(104)} \sim 8.8$ . The plasma oxidation for Cr<sub>2</sub>O<sub>3</sub> improved the dielectric breakdown strength from 0.3 V to 1 V, indicating the reduction of the oxygen vacancies in Cr<sub>2</sub>O<sub>3</sub>. The MTJs with the plasma oxidized Cr<sub>2</sub>O<sub>3</sub> barrier showed the tunnel magnetoresistance (TMR) ratio of 1% (4%) at 300 K (10 K). As the temperature decreased to < 100 K, the TMR curves showed the increase of coercive fields and anisotropy in the Co layer, indicating antiferromagnetic order of Cr<sub>2</sub>O<sub>3</sub>.

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## References

- [1] V. Baltz et al., Rev. Mod. Phys. 90, 015005 (2018).
- [2] K. Wang et al., Sci. Rep. 5, 15498 (2015).